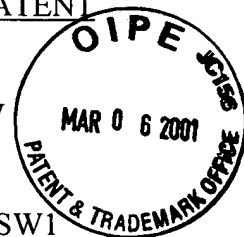


S/N 09/208,105

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|             |  |                 |              |
|-------------|--|-----------------|--------------|
| Applicant:  | SAKAMOTO   | Examiner:       | O. NADAV     |
| Serial No.: | 09/208,105   | Group Art Unit: | 2811         |
| Filed:      | NOVEMBER 25, 1998  | Docket No.:     | 10233.81USW1 |
| Title:      | SEMICONDUCTOR DEVICE WITH METAL WIRE LAYER MASKING (AS AMENDED HEREIN) |                 |              |



CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited in the United States Postal Service, as first class mail, with sufficient postage, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 28, 2001.

By:

Name:

*Kristine A. Graceh*  
*Kristine A. Graceh*

AMENDMENT UNDER RULE 111

Assistant Commissioner for Patents  
Washington, D.C. 20231



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Dear Sir:

In response to the Official Action dated September 29, 2000, please amend this application as follows:

In the Specification

Please change the title from "SEMICONDUCTOR DEVICE AND A METHOD FOR MANUFACTURING THEREOF" to --SEMICONDUCTOR DEVICE WITH METAL WIRE LAYER MASKING--.

Page 1

Line 22, change "Surface" to --The surface--.

Line 24, change "17" to --22--.

Page 2

Line 8, change "irradiated" to --irradiate--.

Line 11, change "shorten" to --shortened--.

Line 15, change "90" to --80--; change "pointed out" to --possible--.